



Docket No.:0756-7257

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: PATENT application of )  
Toru TAKAYAMA, et al. )  
Serial No. 10/787,165 ) Group Art Unit: 1763  
Filed: February 27, 2004 ) Examiner: G. Goudreau  
For: METHOD FOR PEELING OFF )  
SEMICONDUCTOR ELEMENT AND METHOD )  
FOR MANUFACTURING SEMICONDUCTOR )  
DEVICE )

**CERTIFICATE OF MAILING**

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Erin L. Lewis

**REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

  
Eric J. Robinson  
Reg. No. 38,285

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